

# Movable Mask Issues

## - History of Movable Mask System -

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23/Feb/2001

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- Introduction
- Ver.1 (original mask)
- Ver.2
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- Ver.4
- Ver.5 } (brand-new mask)
- Summary

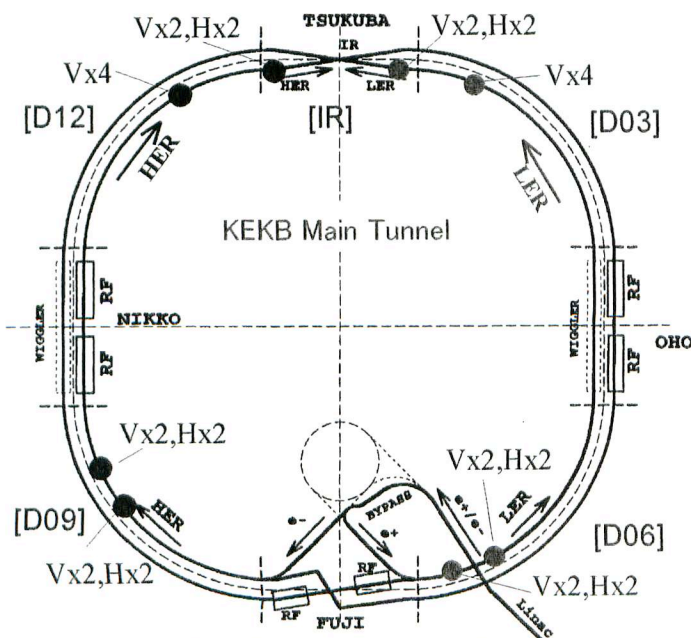


## Purpose of movable mask (collimator)

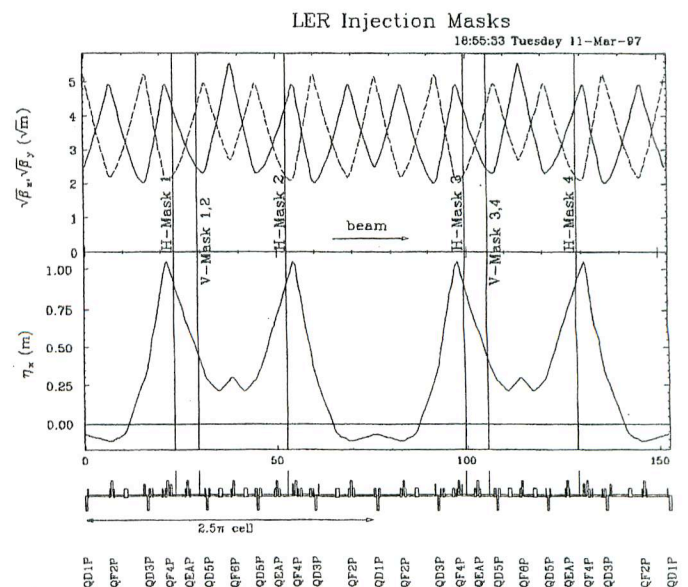
Protect the BELLE detector against

{ off-momentum particles  
particles with a large  
betatron oscillation

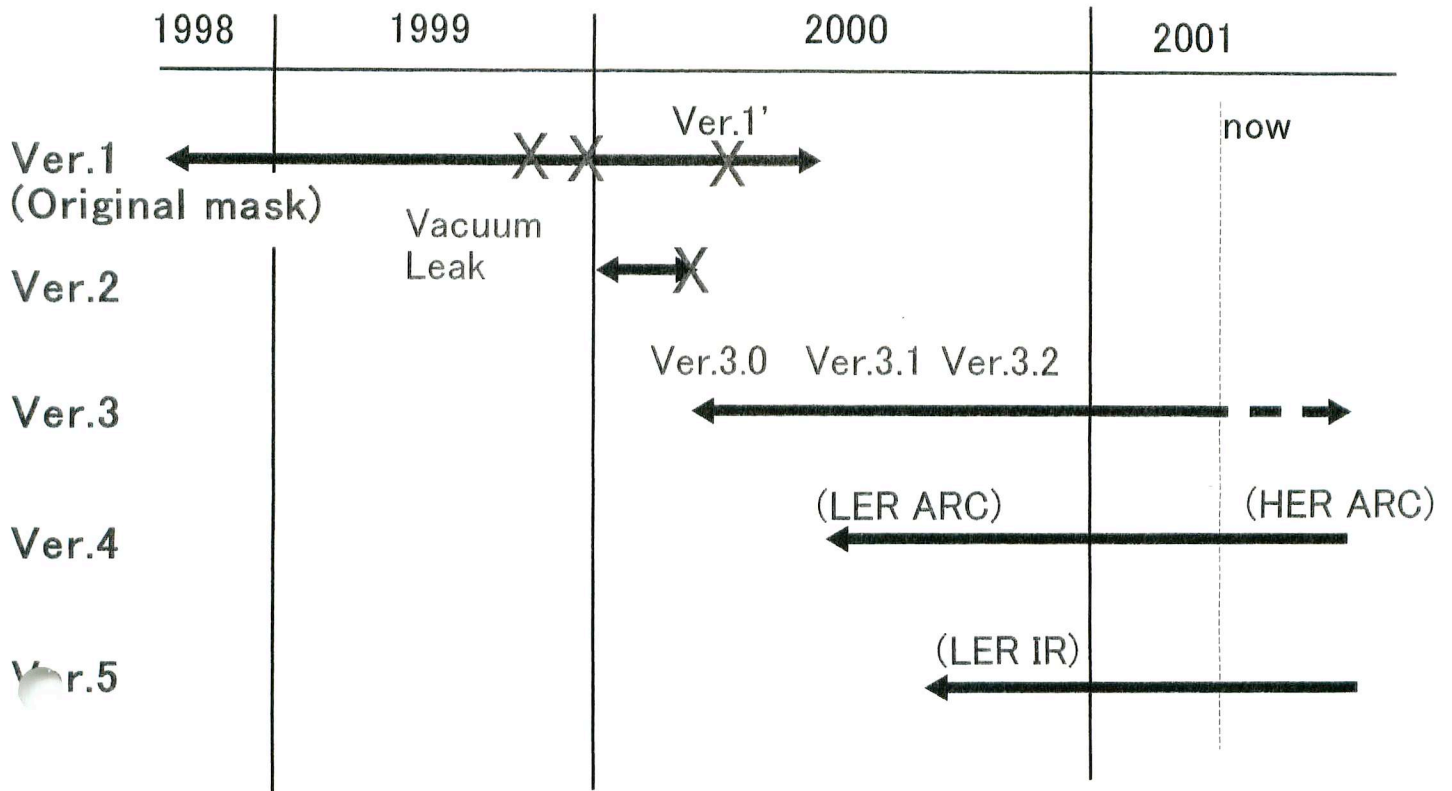
### Original mask location in the ring



### Location on the lattice diagram



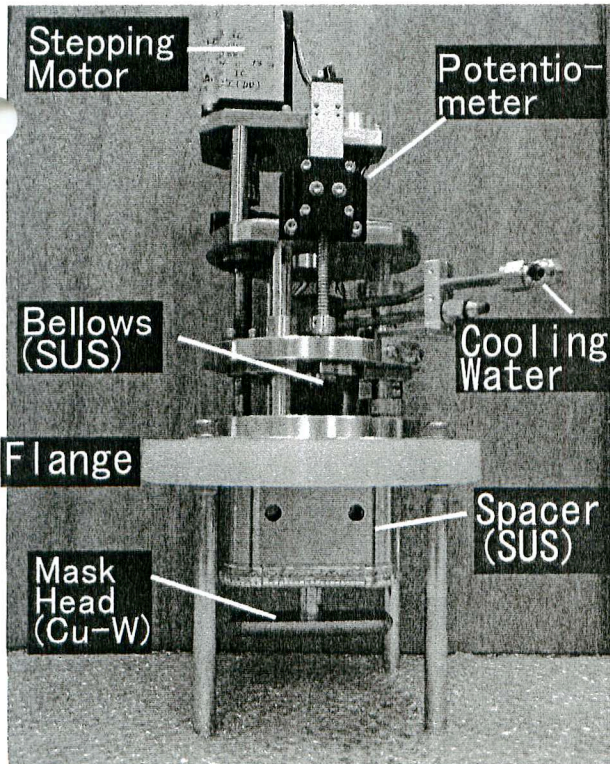
# Histories of masks



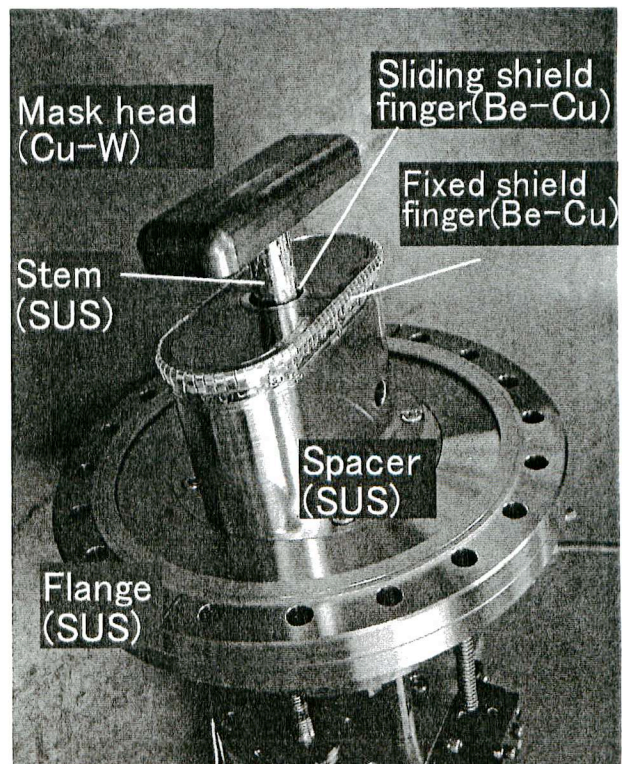
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## Ver.1 (original mask)

Whole view

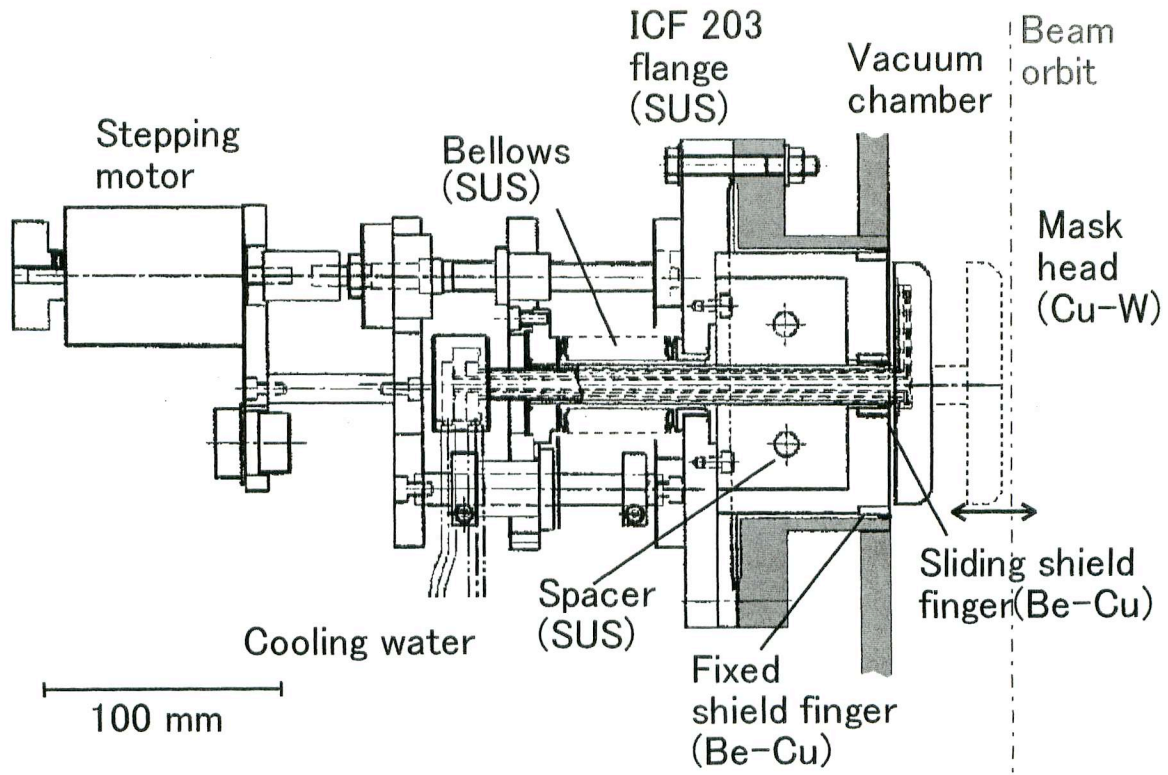


Vacuum side



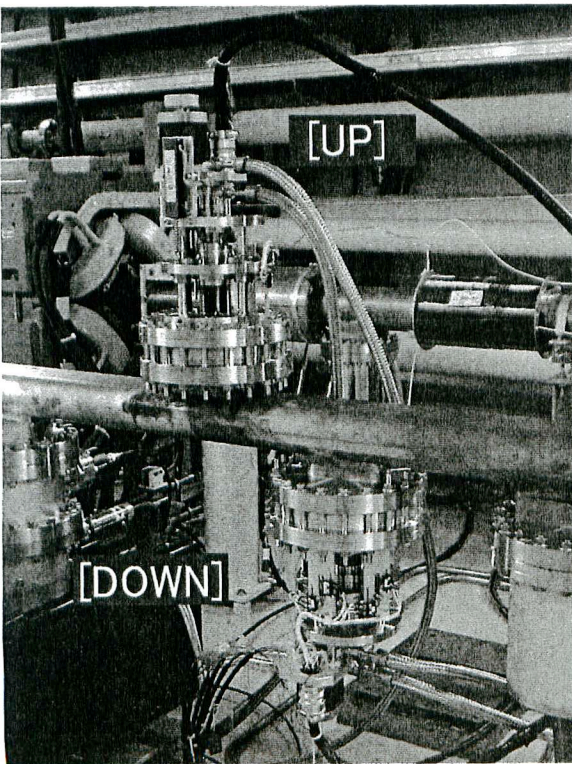
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# Ver.1 Structure (cross section)

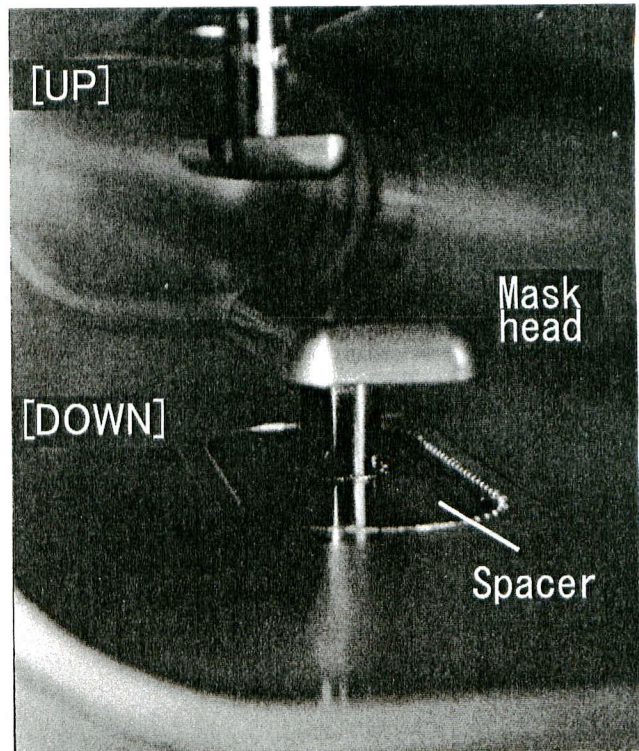


# Ver.1(Ver.2, 3) Setup in the tunnel

Outlook (HER)



Inside of beam chamber (HER)



## Ver.1 Troubles (began at the beam current $> 500$ mA)

### (1) Damage of sliding the shield fingers

Fingers were broken (melted) and welded to the stem.

### (2) Excess heating

Depending on the buch fill pattern and the mask position, the bellows temperature increased abnormally.  $\longrightarrow$  Vacuum leak

### (3) Arcing

Arcing occurred between the stem and the spacer.  
Broken fingers became a sharp electrode for discharge.

$\longrightarrow$  Vacuum leak

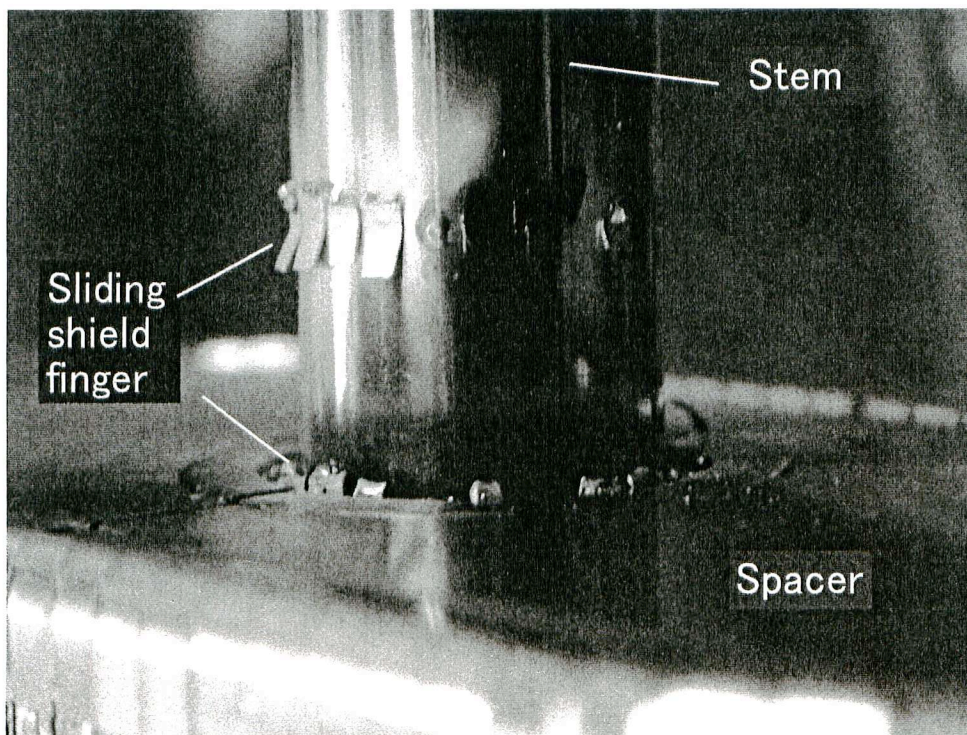
### (4) Excitation of beam oscillation

Strong synchrotron oscillation was excited.

### (5) Digging of mask head

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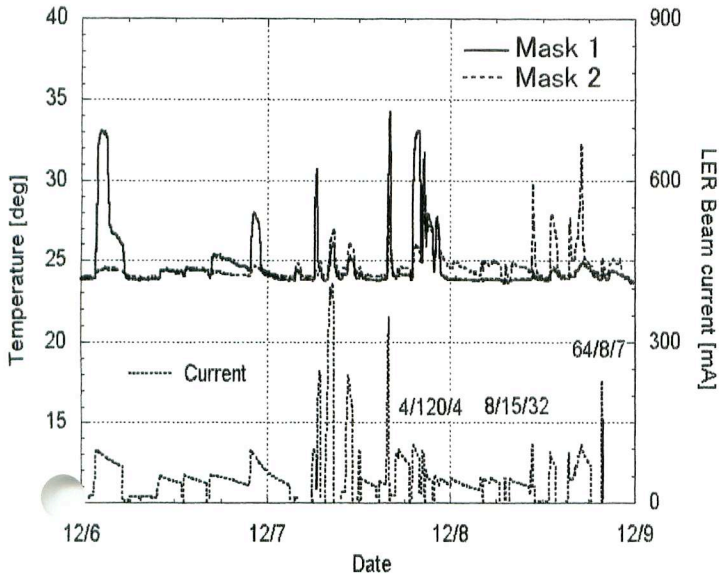
## Ver.1 Broken shield finger



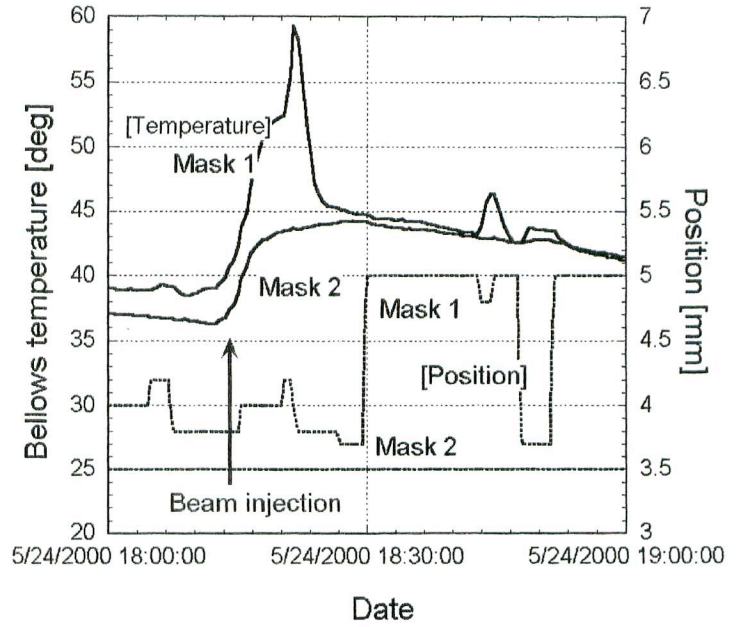
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# Ver.1 Excess heating

## Bunch fill pattern dependence of mask temperature

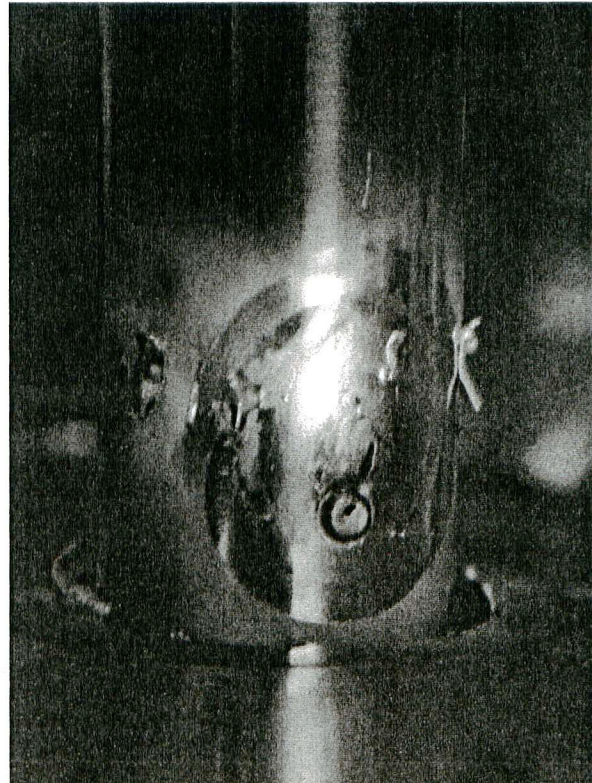
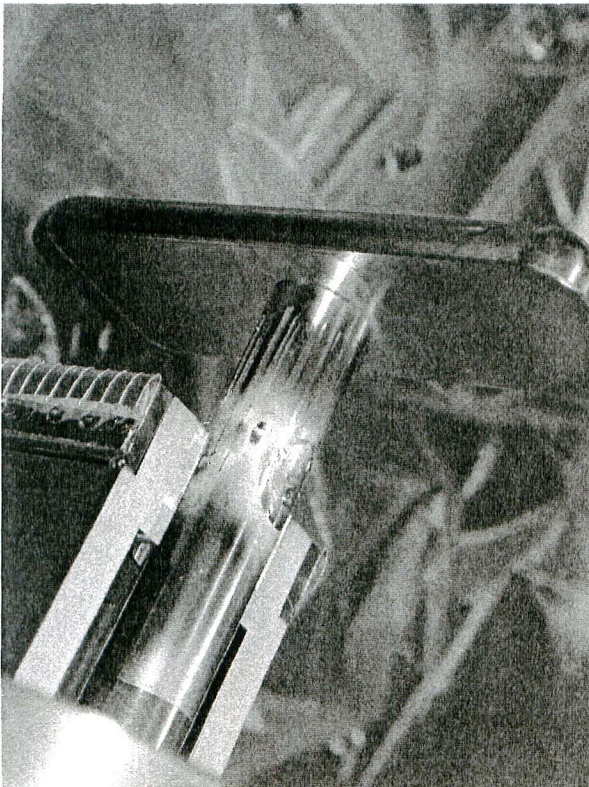


## Mask position dependence of mask temperature



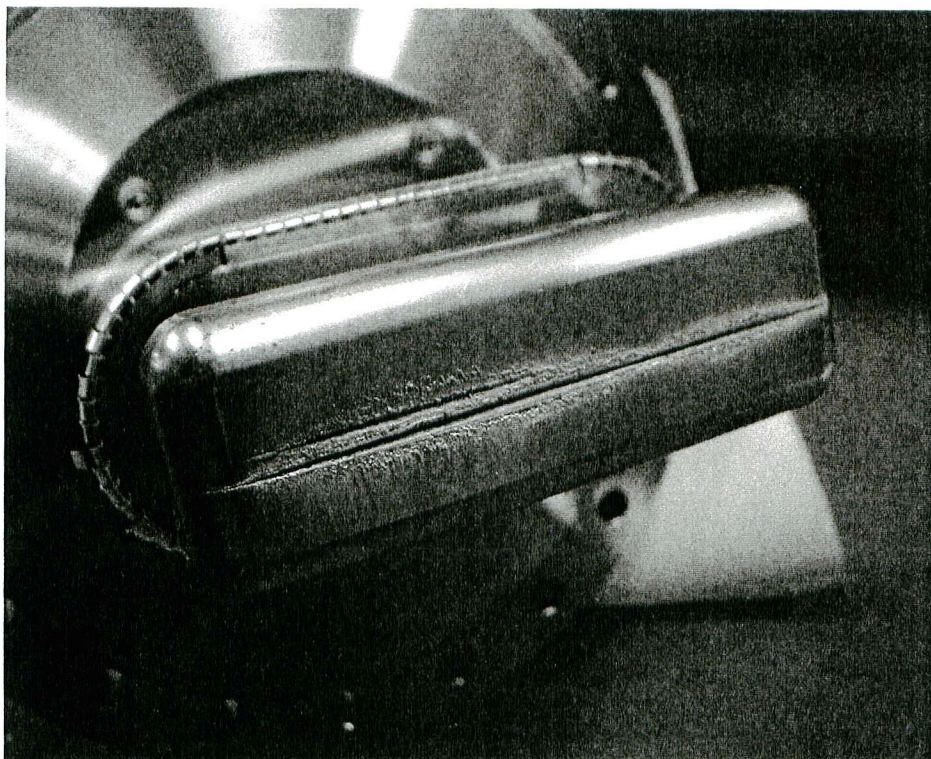
# Ver.1 Arcing between spacer and stem

→ Vacuum leak



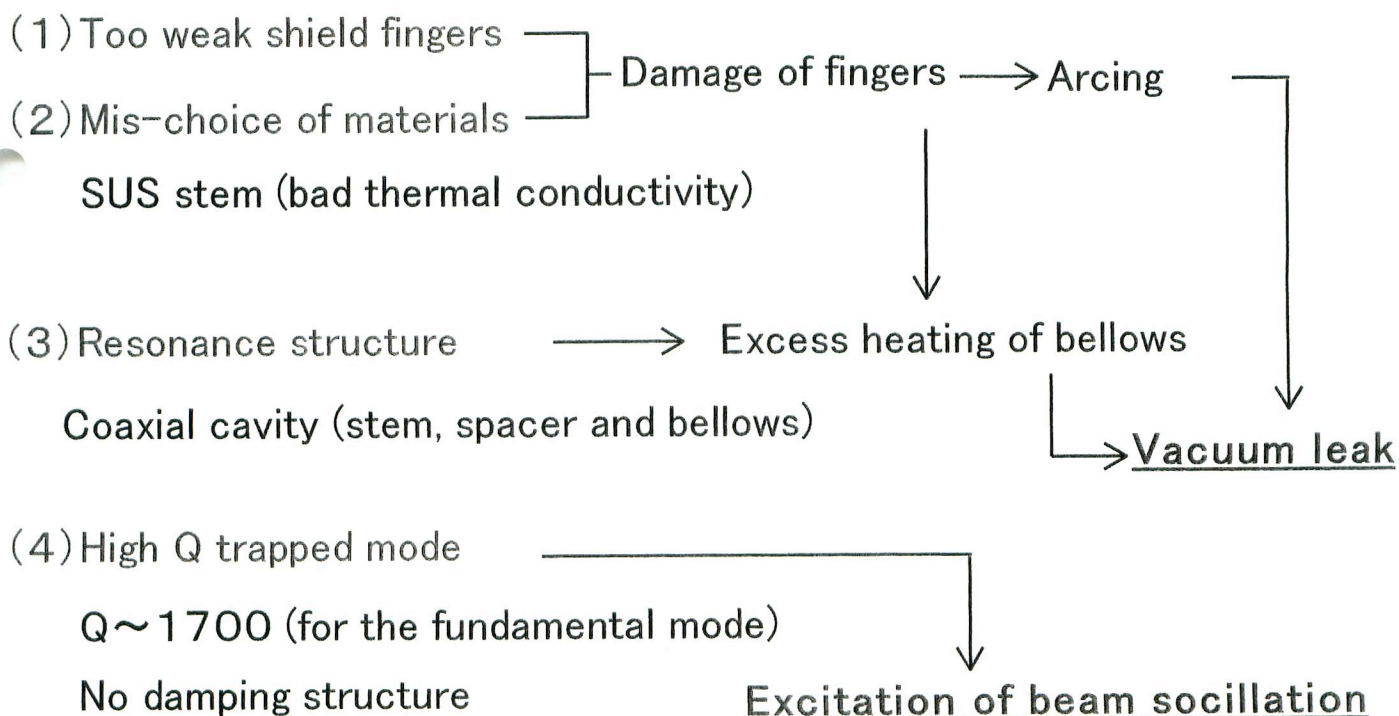
# Ver.1 Grooves on mask head

Cu-W mask head



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## Ver.1 Causes of troubles

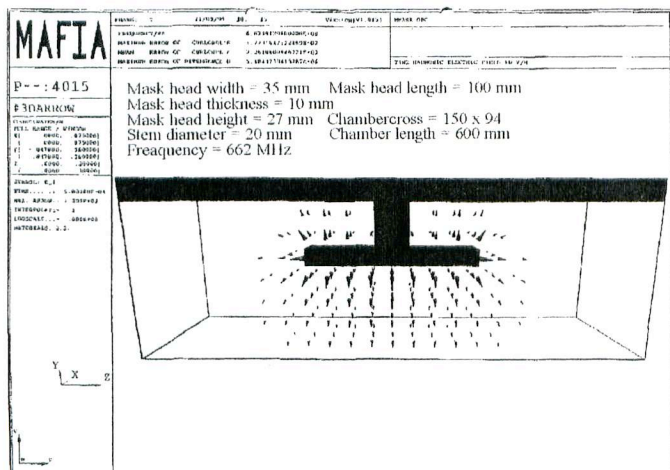


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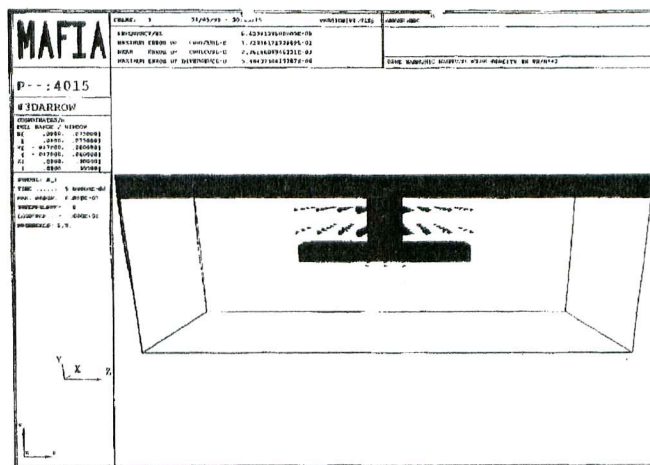
# Ver.1 Trapped mode

A example of mode calculation using MAFIA code

Electric field



Magnetic field



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# Ver.1 Countermeasures

(1) Too weak shield finger

For the time being, remove all sliding shield fingers → Ver.1's mask

(2) Heating

For the time being, keep watch on temperature at bellows and cool the bellows by a blower

(3) Resonance structure

(4) High Q trapped mode



Design of new masks well coped with heating and RF problems

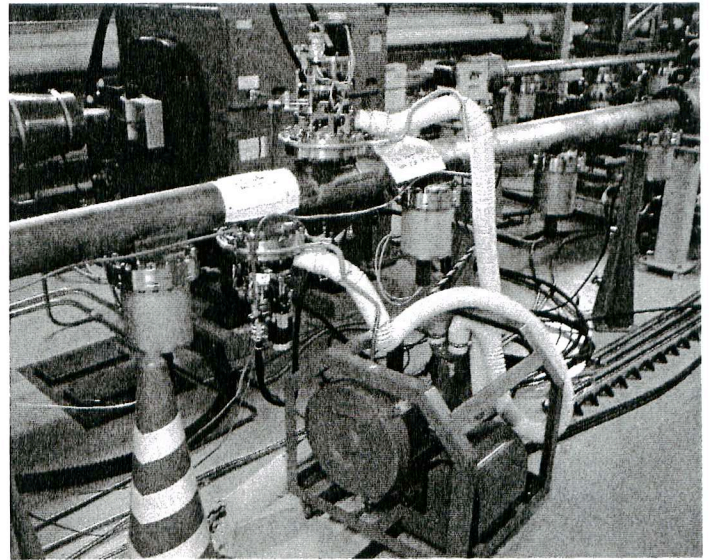
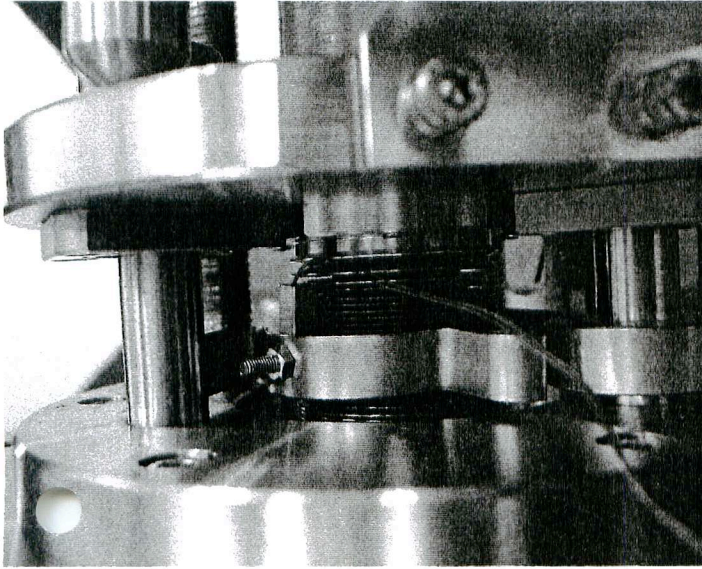
(5) Digging of mask head → Change of mask head material  
CuW → Cu

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# Ver.1 Countermeasures for the time being

Thermometer (PtR) at bellows pleats

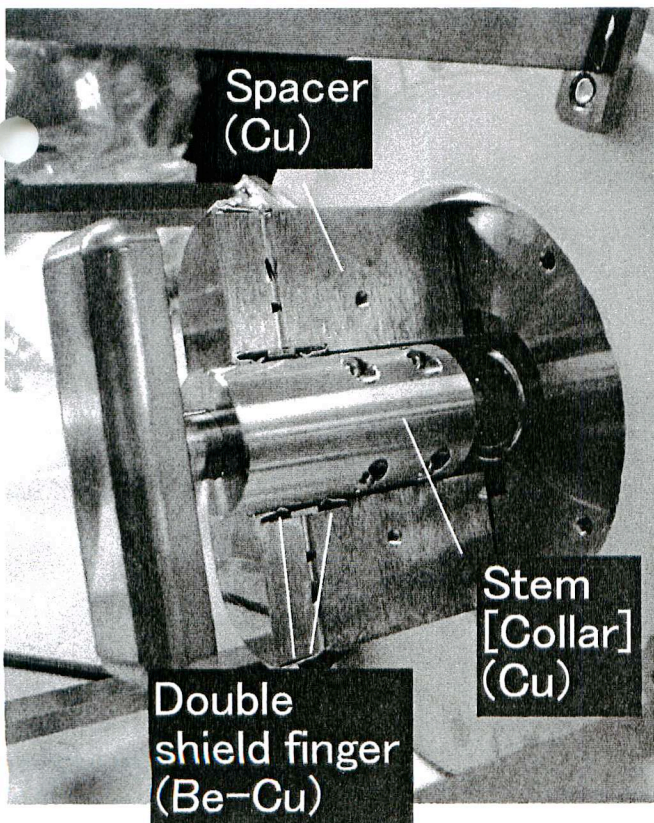
Cooling by a blower



(Platinum resistance thermometer)

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## Ver.2 (prepared to meet an immediate need)



Features

- Low current density at the sliding shield finger  
(Stem diameter 16 mm  $\rightarrow$  36 mm)
- Double sliding shield finger

But

- Q factor is still high ( $\sim 2000$ )  
RF properties are the same as Ver.1

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# Ver.2 Troubles

When the Ver.2 masks were approached to the beam,  
a strong synchrotron oscillation was excited.



↳ Limit the current

All Ver.2 masks were set at full the open position.



Arcing occurred between the old stem (inside of collar)  
and the edge of spacer.

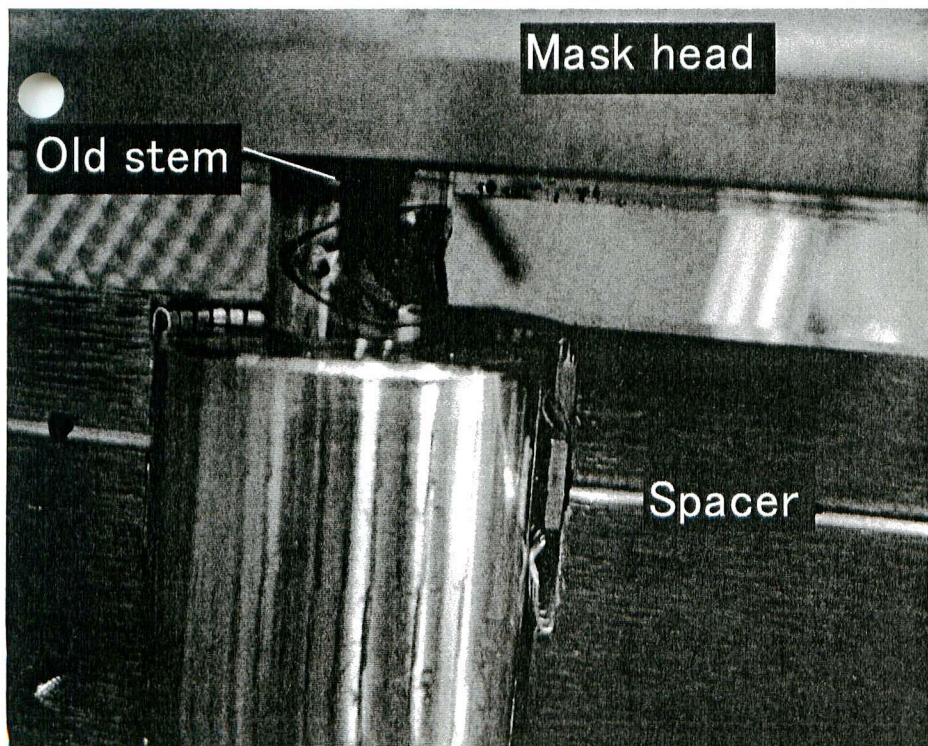


Vacuum leak !

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## Ver.2 Vacuum leak

Arcing between the old stem and spacer



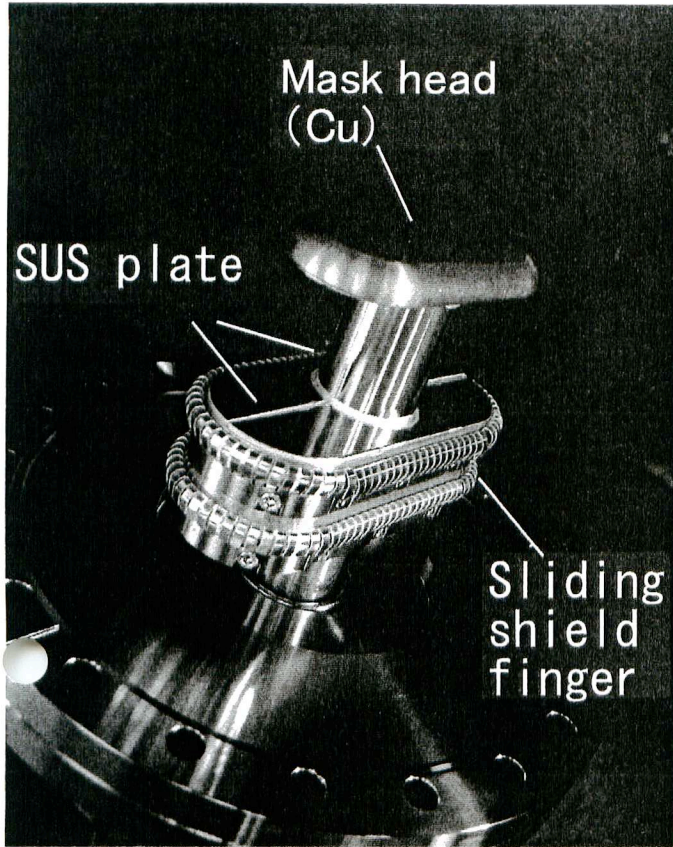
All Ver.2 masks were  
immediately removed.

(Very short-lived mask)

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Ver.3.0 – 3.2 (After all, a filler until new masks are prepared)

## Ver.3.0



### Features

- Low current density at sliding shield finger (around spacer)
- Double shield finger
- Low Q ( $\sim 600$ ) compared to Ver.1 with SUS plate
- Existing chamber is available
- Cu mask head (CuW  $\rightarrow$  Cu)

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## Ver.3.0 Troubles

The Q-factor was still too high.

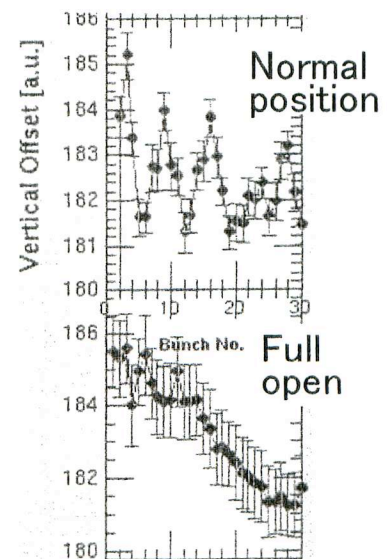
- A synchrotron oscillation was excited again.
- COD in a bunch train was observed.



The mask head was set at the full open position.



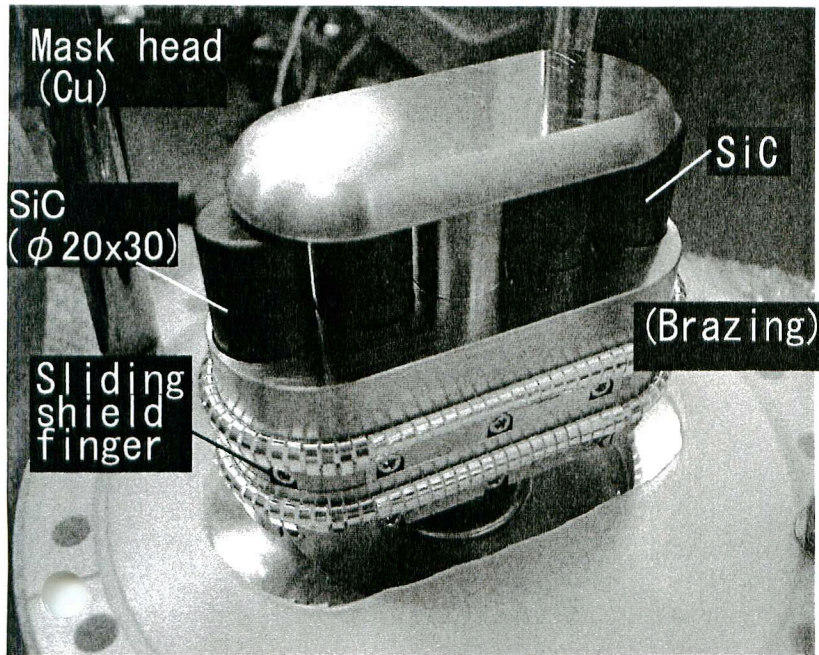
Ver.3.1 and Ver.3.2 masks with RF damping structure were developed.



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# Ver.3.1, 3.2

## Masks with HOM damper



### Features

- Basic structure is the same as Ver.3.0.
- HOM damper (SiC) is equipped.

Low Q (~40)

- In calculation, the input power of SiC is reasonable unless the frequency of a trapped mode and that generated by the beam are matched.



## Ver.3.1 Troubles

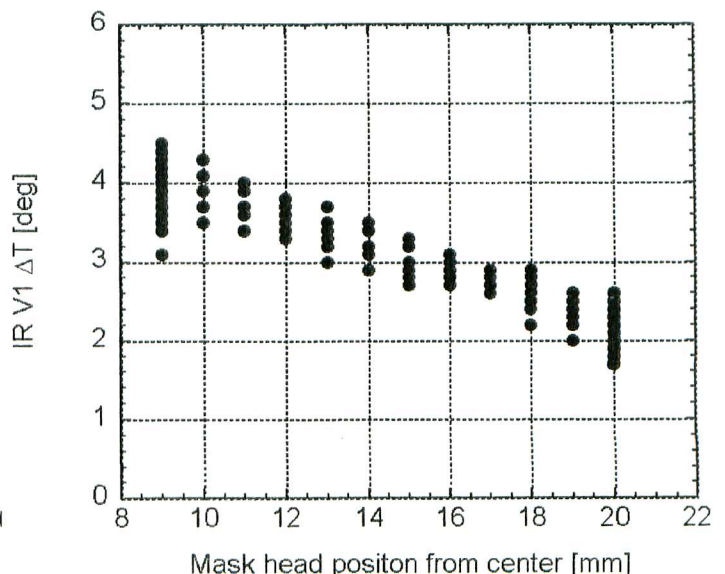
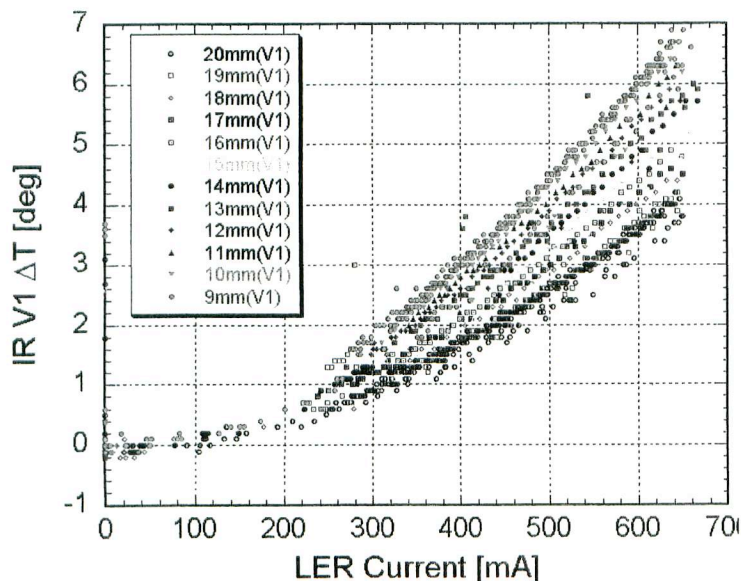
Larger input power than expected

~500 W/SiC at 600 mA (LER)

The temperature increased monotonically as the mask head approached the beam.

→ Not a resonance

→ The SiC is absorbing HOM generated at the mask itself.



## Ver.3.1 Troubles

An SiC has broken

After the operation at 700 mA for about 2 months, one SiC was found to be broken.

Before installation?  
Too high input power?

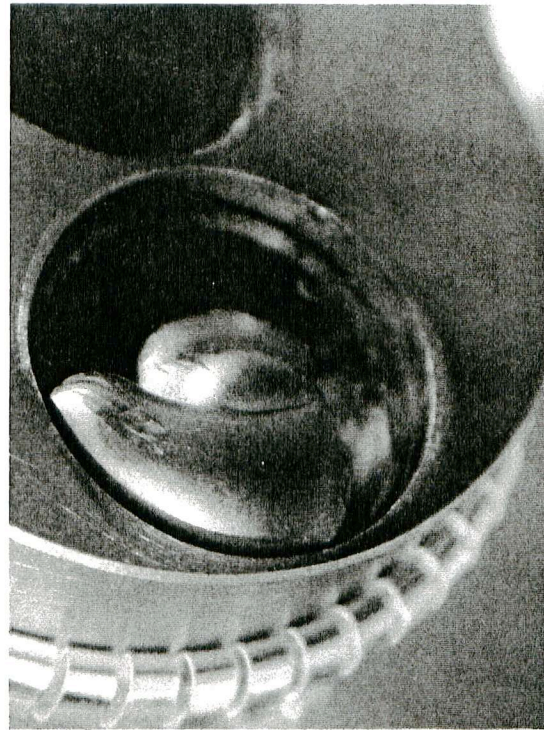
LER beam current was limited at 500 W/SiC (larger than the past achievement)



To play it safe, Ver.3.1 cannot be used for LER anymore.



New masks Ver.4, 5



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## Ver.3.2 (temporally prepared for HER vertical)

Ver.3.2

### Features

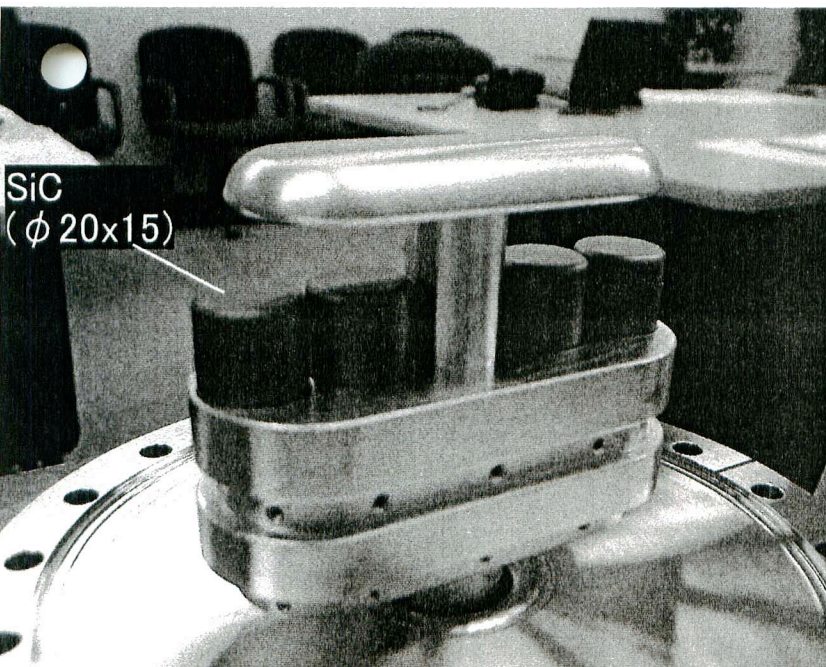
- Basic structure is the same as Ver.3.1
- The height of SiC was shorten to half 30 mm --> 15 mm

Now HER beam current was limited at

Maximu input power < 250 W/SiC



Ver.4



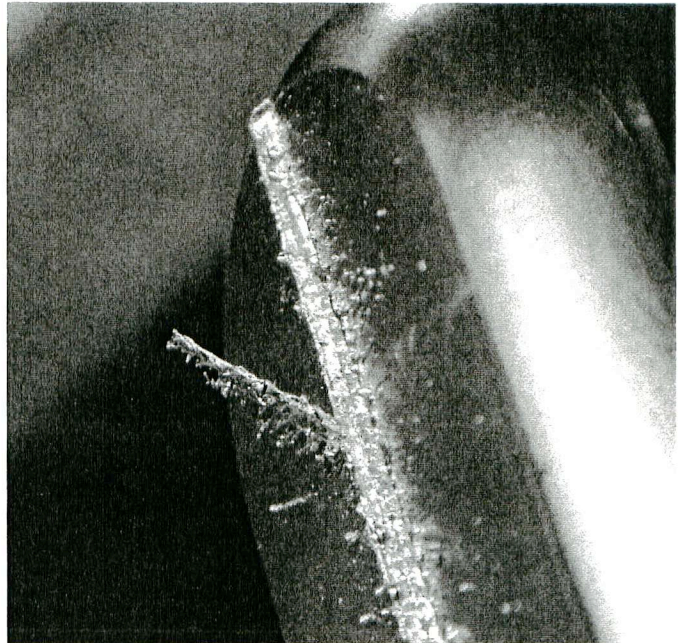
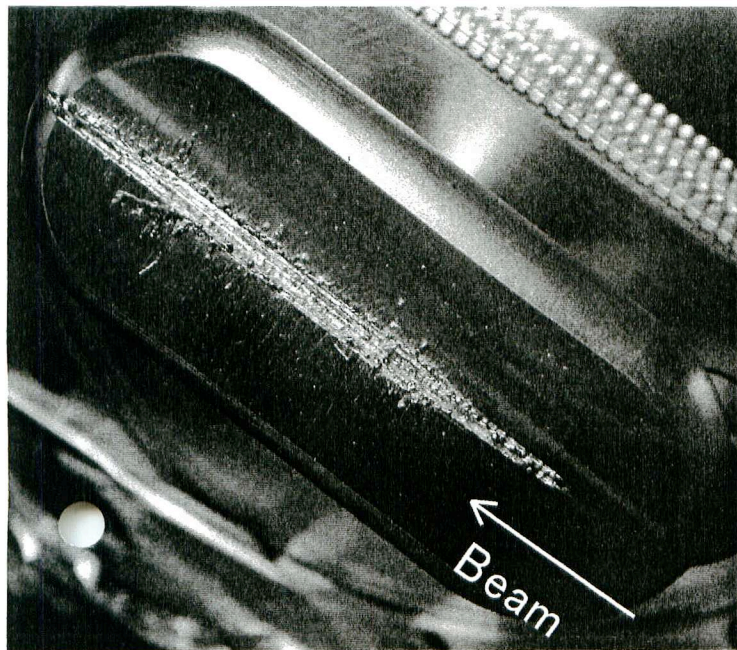
(Before attaching sliding shield finger)

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# Ver.3.2 Troubles

## Groove on the mask head (Cu)

The head has melted. The whisker was objecting the beam.



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## Groove on mask head

### Possible Cause

(1) Abrupt change of orbit

Setting of a abnormal bump

(2) Vertical blowup of beam size or vertical oscillation

One possible stroy

Energy loss (a few %)

For an example, down of a  
(superconducting) cavity

Slippage from the regular optics or  
feed-back timing

Vertical blowup of beam size or  
vertical oscillation

Generation of groove (further study is necessary)

{ Fast loss monitor  
Fast sensor of RF phase

may help mask

The problem will be  
occured even for  
new masks.

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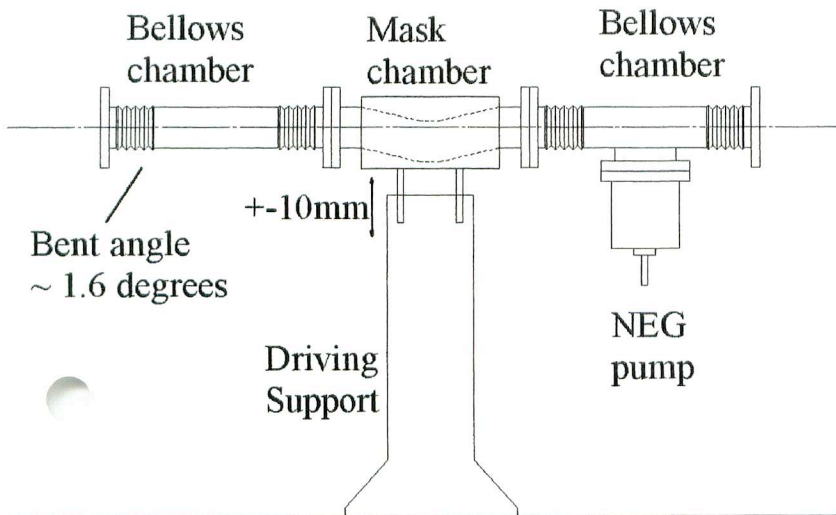
# Ver.4 (the ultimate weapon for arc section)

## Basic structure

Use a bent chamber as a mask.

## Features

- Free from trapped modes (HOM is excited.)



But

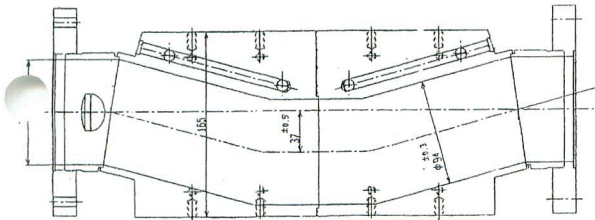
A space of several meters is necessary.

Available for arc section

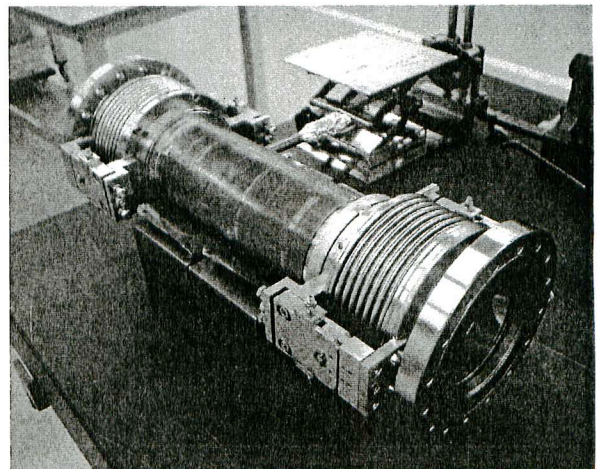
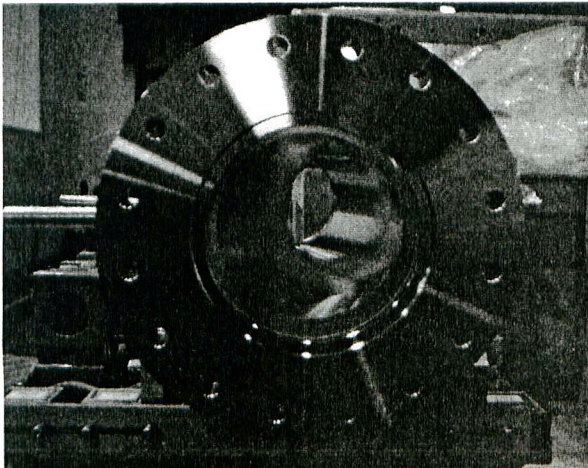
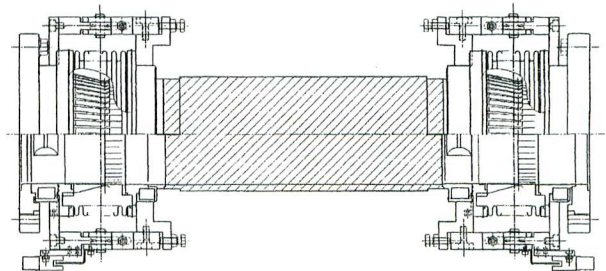
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## Ver.4 Components

Mask chamber (LER)

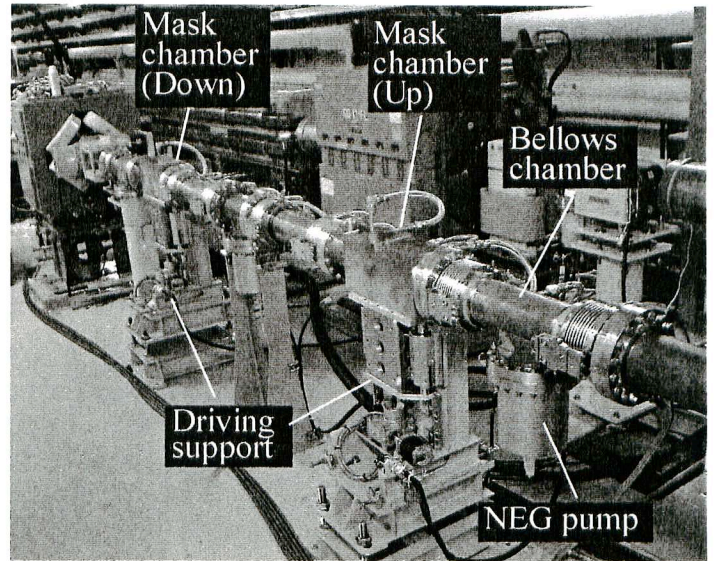
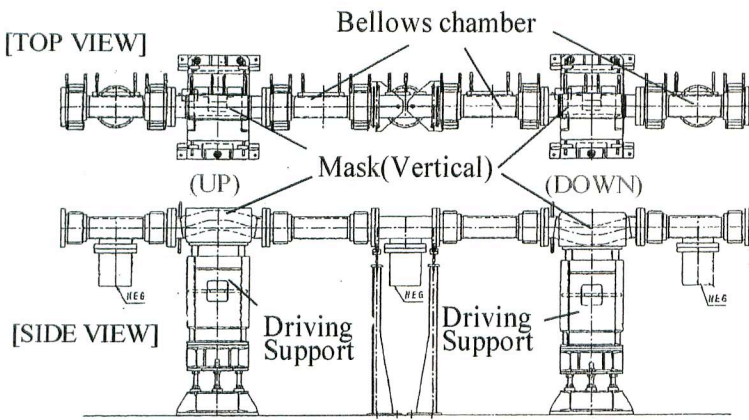


Bellows chamber (LER)



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# Ver.4 set up in the tunnel (vertical)

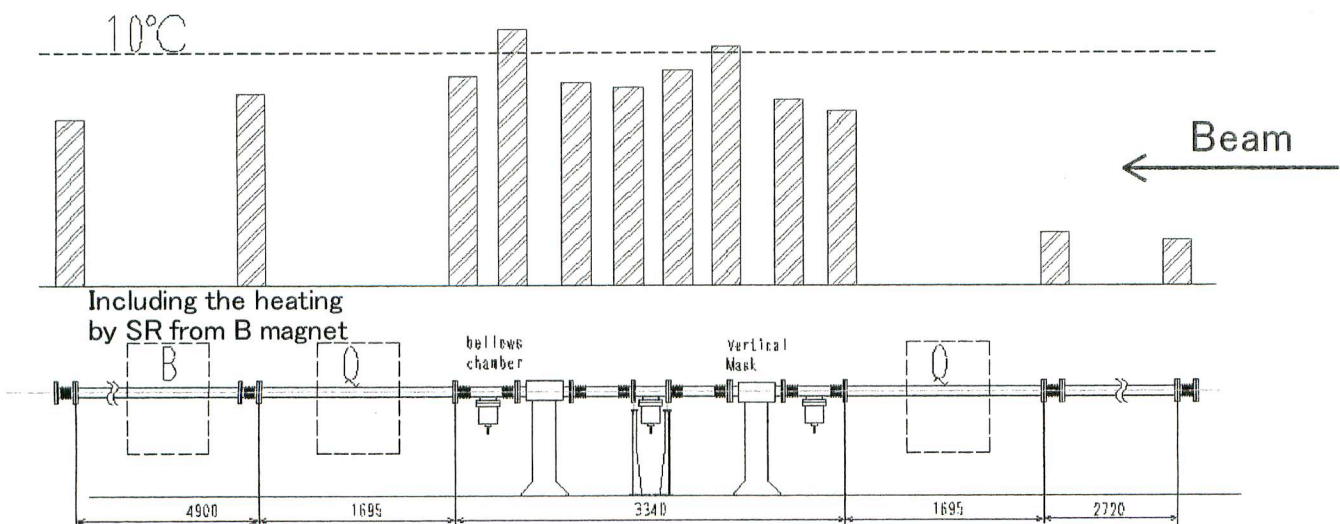


## Temperature rises of bellows around Ver.4 masks

Temperature rises at bellows around Ver.4 masks are higher than other bellows.

Temperature rise at 600 mA (LER)

Max.  $\Delta t = 35^\circ\text{C}$

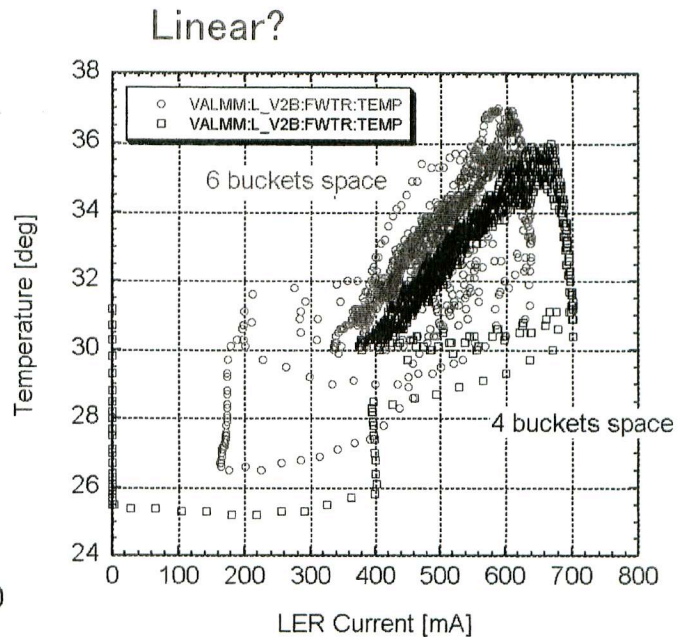
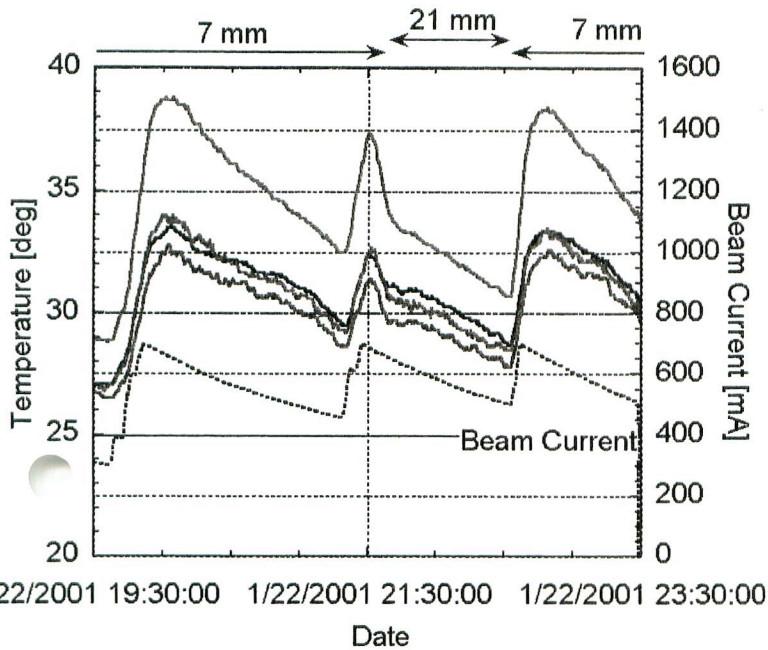


# Temperature rise of bellows

Due to { HOM generated by the mask?  
scattered SR?

Mask position dependence of bellows temperature near masks.

Fill pattern dependence of bellows temperature near masks.



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## Present status of Ver.4 mask

(1) There is no fatal trouble up to now.

- Maximum beam current is 780 mA (LER).
- No grooves was found for LER up to now.

(2) Temperature rise of bellows near Ver.4 mas is higher than others

- Main cause is HOM and/or scatterd SR?

Further studies are necessary.

- We have to keep watching.

(3) Check of grooves at regular intervals is necessary.

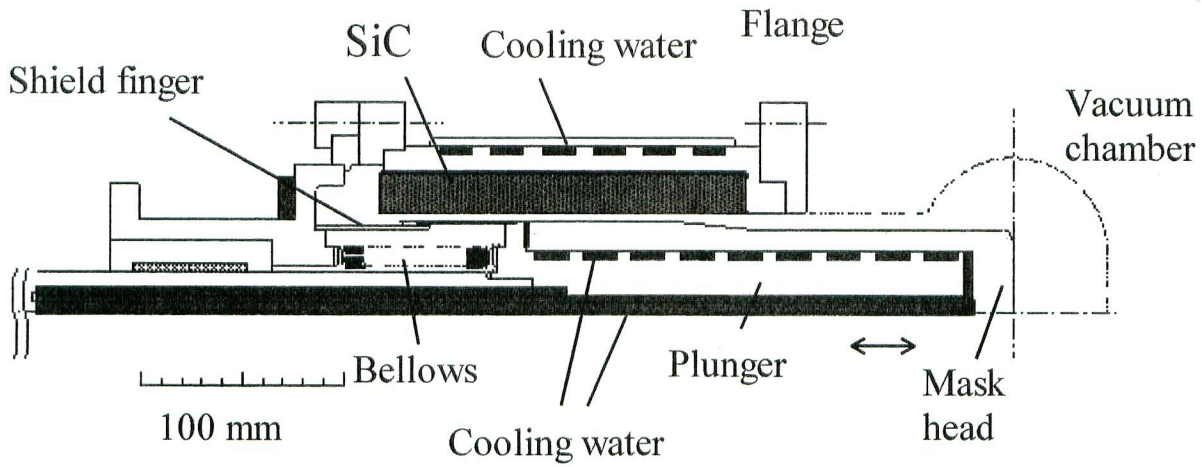
Prepare peeking hole for HER masks and spare masks.

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# Ver.5 (the ultimate weapon for IR)

## Structure (cross section)



## Features

HOM is heavily dumped by SiC dumper.

$$Q < 10$$

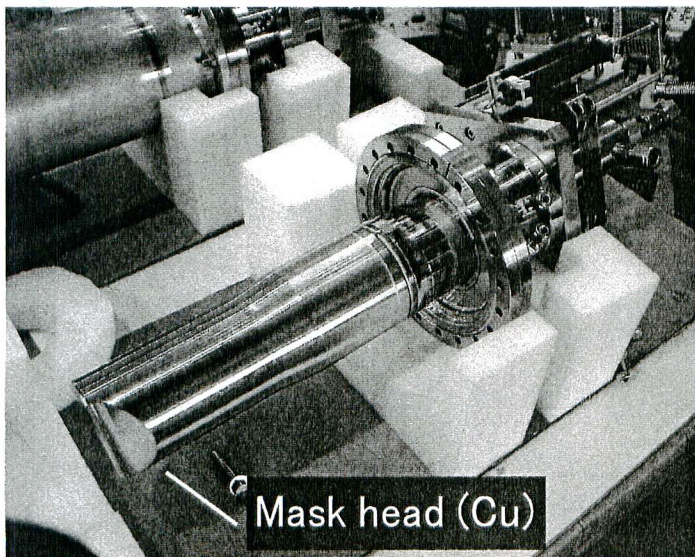
Designed power capacity is 10 kW

Available for narrow space

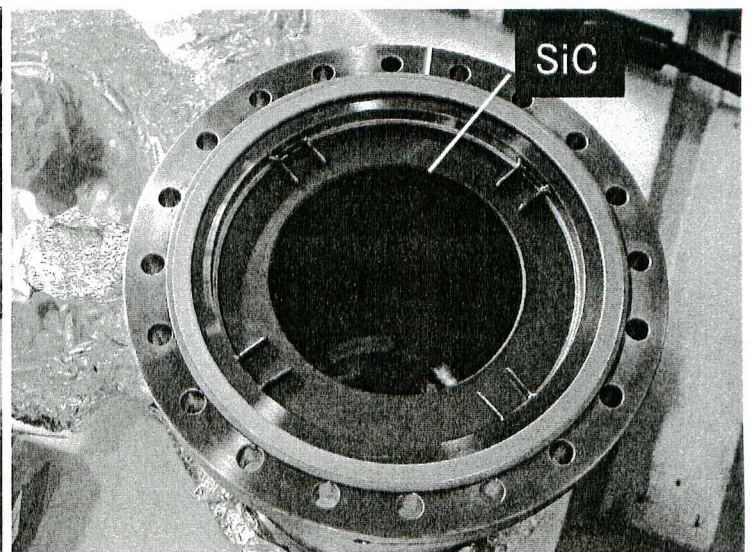
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## Ver.5 Components

Mask (plunger)

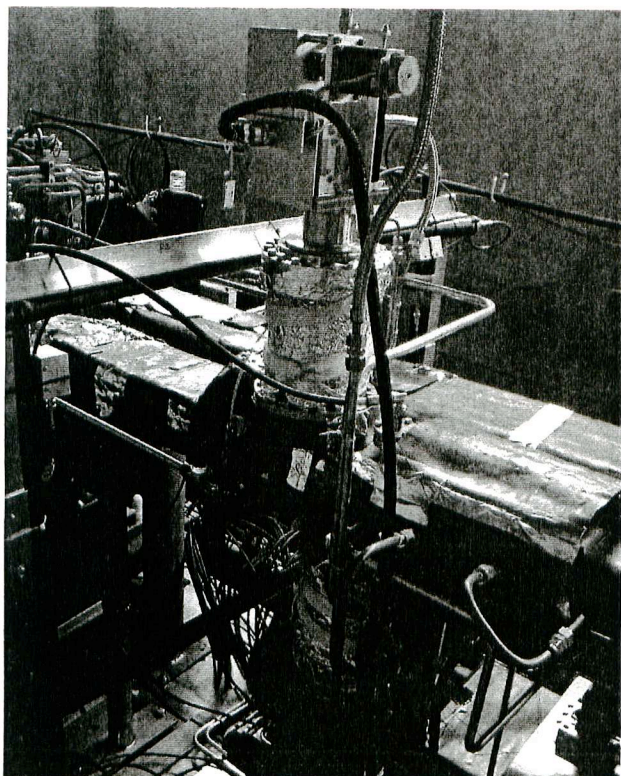


SiC duct (HOM dumper)

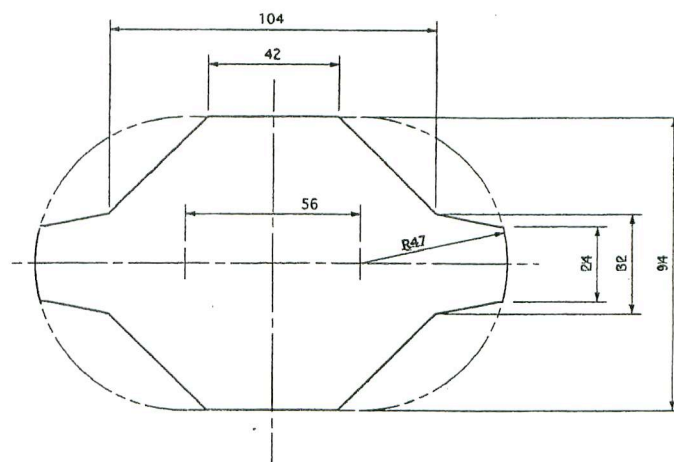


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# Ver.5 set up in the tunnel for LER IR (Vertical)

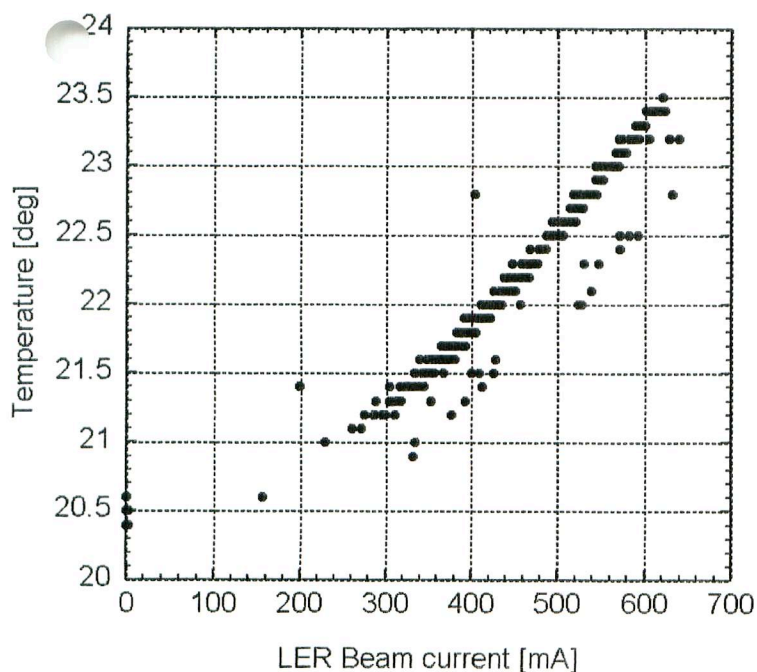


Cross section of the chamber is changed to adjust the mode frequency



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## Present status of Ver.5 mask



(1) Estimated input power

~ 800 W at 500 mA



~ 4 kW at 2600 mA

No problem

(2) Check of grooves at regular intervals is necessary.

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# Summary

(1) Old masks (Ver.1 – Ver.3) had various problems and troubles.

Excess heating, Arcing --> Vacuum leaks  
Excitation of beam oscillations

Mask problems had been limiting the stored beam currents.

(2) New masks (Ver.4 and 5) well coped with RF and heating problems are developed

They are working well.

(3) All masks in HER arc will be replaced to Ver.4.

All masks in the KEKB are changed to new ones this year.

(4) Grooves on mask head have to be kept watching

Fast abort system should be prepared.

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The logo for KEKB Factory, featuring the text "KEKB Factory" in a stylized, bold, italicized font with a 3D effect, positioned at the end of two horizontal lines.